

71480 U.S. PTO



02/27/97

Docket: 0756-1638

Date: February 27, 1997



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

REQUEST FOR FILE WRAPPER CONTINUING APPLICATION

UNDER 37 CFR 1.62

14/C
Shawton
5/23/97
NOT TO GO 1104

Honorable Assistant Commissioner for Patents

Box FWC

Washington, D.C. 20231

Sir:

This is a Request for filing a

[X] Continuation [] Divisional

under 37 CFR 1.62 of prior pending application

Serial No. 08/479,211

Art Unit: 1104

Filed: June 7, 1995

Examiner: L. Radomsky

Entitled: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

by the following named inventors:

Hisashi OHTANI, Akiharu MIYANAGA

Hongyong ZHANG

Naoaki YAMAGUCHI

The above identified prior application in which no payment of the issue fee, abandonment of, or termination of proceedings has occurred, is hereby expressly abandoned as of the filing date of this new application. Please use all the contents of the prior application file wrapper, including the drawings, as the basic papers for the new application. (Note: 37 CFR 1.60 may be used for applications where the prior application is not to be abandoned.)

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1. ☒ To the best of information and belief, the current correspondence address of the inventor(s) is as set forth in the Declaration filed in the parent application.
2. ☐ Enter the amendment previously filed in the prior application on _____ under 37 CFR 1.116, but unentered.
3. ☒ A preliminary amendment is attached.
4. The filing fee is calculated on the basis of the claims existing in the prior application as amended at 2 and 3 above.

For:	No. Filed		No. Extra	Rate Sm/Lg Entity	Fee
Basic Fee		--	--	\$385/770	\$770.00
Total Claims	15	- 20	0	x 11/22	
Independent Claims	3	- 3	0	x 40/80	
First presentation of multiple dependent claims				\$130/260	
Total					\$770.00

5. ☒ Amend the specification by inserting before the first line, the sentence:

--This application is a Continuation of Serial No. 08/479,211, filed June 7, 1995, now abandoned; which itself is a continuation-in-part of Serial No. 08/391,580, filed February 21, 1995. --*Now U.S. Pat No. 5,605,846*

6. ☒ A check in the amount of \$1,160.00 is enclosed.
Includes two month extension of time fee.
7. ☐ The small entity status established in the parent application continues to be applicable and such small entity status is hereby requested for the present application.

8. [X] Priority is claimed under 35 USC 119 based on foreign application(s)
No.(s) 6-51237
Filed in (country) Japan
On (date): February 23, 1994
[] Certified copy (copies) attached.
[X] Certified copy (copies) filed on February 21, 1995 in prior
United States Serial No. 08/391,580 filed on February 21,
1995.
9. [X] The prior application is assigned of record to Semiconductor Energy
Laboratory Co., Ltd.
10. [X] The power of attorney in the prior application is to:
- | | |
|-------------------------|-----------------|
| Daniel W. Sixbey | Reg. No. 20,932 |
| Stuart J. Friedman | Reg. No. 24,312 |
| Charles M. Leedom, Jr. | Reg. No. 26,477 |
| Gerald J. Ferguson, Jr. | Reg. No. 23,016 |
| David S. Safran | Reg. No. 27,997 |
| Thomas W. Cole | Reg. No. 28,290 |
12. [X] The Commissioner is hereby authorized to charge fees under 37 CFR
1.16 and 1.17 (except the issue fee) which may be required now or
hereafter, or credit any overpayment, to Deposit Account No. 19-2380.
A duplicate of this form is attached.
13. [X] It is hereby petitioned under 37 CFR 1.136 that the response term in
the prior pending application be extended, if necessary, to a date
which includes the filing date of the present application, and the
Commissioner is hereby authorized to charge any necessary extension
fee to Deposit Account No. 19-2380. The prior pending application
is hereby expressly abandoned upon the award of a filing date to this
application.

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14. [X] Also enclosed:
Petition for Extension of Time

Address all future correspondence to:

SIXBEY, FRIEDMAN, LEEDOM & FERGUSON, P.C.
2010 Corporate Ridge, Suite 600
McLean, Virginia 22102
(703) 790-9110

Respectfully submitted,



Jeffrey L. Costellia
Registration No. 35,483

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2010 Corporate Ridge, Suite 600
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(703) 790-9110

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Application of)
Hisashi OHTANI et al.)
Based On Serial No. 08/479,211) Art Unit: 1104
Which Was Filed: June 7, 1995) Examiner: L. Radomsky
For: METHOD FOR)
MANUFACTURING)
SEMICONDUCTOR DEVICE) Date: February 27, 1997

SUBMISSION OF RELATED APPLICATIONS

Honorable Assistant Commissioner for Patents

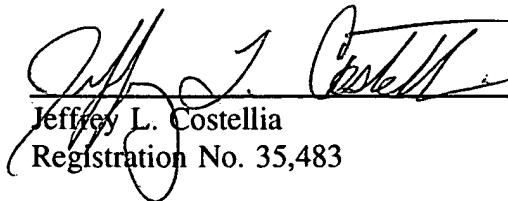
Washington, D.C. 20231

Sir:

Pursuant to Applicant's duty of candor under 37 C.F.R. §1.56, Applicant wishes to inform the Examiner of the following applications directed to related technical subject matter:

<u>Serial No.</u>	<u>Filing Date</u>	<u>Title</u>
08/258,210	June 10, 1994	SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

Respectfully submitted,



Jeffrey L. Costellia
Registration No. 35,483

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08/258,210